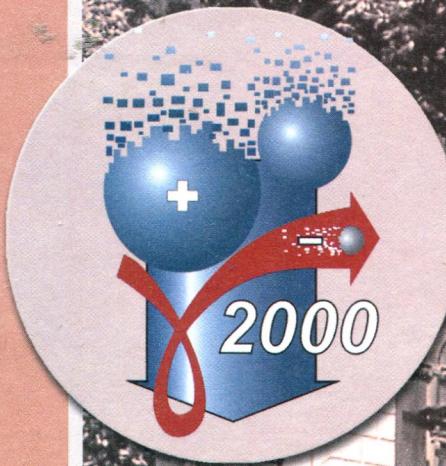


*Tomsk, Russia, 24 - 29 September 2000*

*Devoted to the Centenary of Studies  
at Tomsk Polytechnic University*



**5th Conference on  
Modification of  
Materials with  
Particle Beams and  
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**Alexander Ryabchikov**

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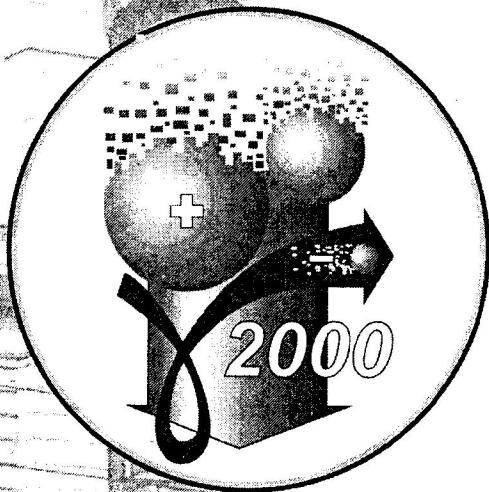
*Institute of High Current Electronics*

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ON RADIATION PHYSICS, HIGH CURRENT ELECTRONICS,  
AND MODIFICATION OF MATERIALS**

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